

L Number	Hits	Search Text	DB	Time stamp
1	2	6309912.pn.	USPAT; EPO; JPO; DERWENT	2004/04/16 10:34
2	2	5188984.pn.	USPAT; EPO; JPO; DERWENT	2004/04/16 10:35
3	2	6417025.pn.	USPAT; EPO; JPO; DERWENT	2004/04/16 10:37
4	2	6590346.pn.	USPAT; EPO; JPO; DERWENT	2004/04/16 10:39
5	1	6693384.pn.	USPAT; EPO; JPO; DERWENT	2004/04/16 10:39
6	3467	445/24-25;313/511,512,500,505,498.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/04/16 11:27
7	127	microstructure and organic and light and display and 313/\$	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/04/16 11:28
8	132	313/\$ and "functional block"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/04/16 11:28
-	2	"20020158577"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 15:47
-	2	6091194.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 18:08
-	7	313/506.ccls. and "functional block"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 18:08
-	0	313/506.ccls. and "nanoblock"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 18:17
-	2	5904545.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 20:05
-	2	5545291.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 19:10
-	140	transparent near2 cathode and 313/506.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 20:39
-	45	microstructure and organic and light and display and 313/\$ and block	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:00
-	6	("3780352"   "5363275"   "5469020"   "5565706"   "5734155"   "5824186").PN.	USPAT	2003/09/12 20:48
-	2	("4990462"   "5091045").PN.	USPAT	2003/09/12 20:50

-	0	09251220.ap.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:00
-	0	09/251220.ap.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:01
-	17	09/251220	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:01
-	17	09/251220 and smith	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:15
-	1	"output pad" with insulation with layer with vias	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:16
-	1010	("output pad" wiring) with insulation with layer with vias	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:16
-	6	((("output pad" wiring) with insulation with layer with vias) and 313/\$	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:25
-	24679	adhesive near3 (via hole)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:25
-	34	((adhesive paste) near3 (via hole)) with (dielectric insulat\$) and 313/\$	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/12 21:41
-	82547	(dielectric insulat\$) with (vias through-hole hole)	USPAT; EPO; JPO; DERWENT	2003/09/12 22:03
-	95	((dielectric insulat\$) with (vias through-hole hole)) and 313/506.ccls.	USPAT; EPO; JPO; DERWENT	2003/09/16 13:22
-	2	6,039,896.pn.	USPAT; EPO; JPO; DERWENT	2003/09/16 15:11
-	2	6291896.pn.	USPAT; EPO; JPO; DERWENT	2003/09/16 15:11
-	32	psa and 313/\$	USPAT; EPO; JPO; DERWENT	2003/09/23 15:08
-	516	pattern\$ near conduct\$ and el	USPAT; EPO; JPO; DERWENT	2003/09/23 16:10
-	418	conduct\$ with nonconduct\$ with layer and display	USPAT; EPO; JPO; DERWENT	2003/09/23 16:15
-	255	conduct\$ with nonconduct\$ with layer and display and pattern\$	USPAT; EPO; JPO; DERWENT	2003/09/23 17:14
-	4	5986400.URPN.	USPAT	2003/09/23 16:19

-	52	conduct\$ with nonconduct\$ with layer same pattern\$ and display	USPAT; EPO; JPO; DERWENT	2003/09/23 16:25
-	1	"5521516".PN.	USPAT	2003/09/23 16:25
-	7	("3885173"   "4144648"   "4422728"   "4641176"   "5175410"   "5216583"   "5379188").PN.	USPAT	2003/09/23 17:11
-	9	conduct\$ with nonconduct\$ with adhesive with layer and display and pattern\$	USPAT; EPO; JPO; DERWENT	2003/09/23 17:22
-	204	conduct\$ with (nonconduct\$ insulat\$) with adhesive with layer and display and pattern\$	USPAT; EPO; JPO; DERWENT	2003/09/23 17:29
-	46	conduct\$ with (nonconduct\$ insulat\$) with adhesive with layer with pattern\$ and display	USPAT; EPO; JPO; DERWENT	2003/09/23 18:36
-	32	4735847.URPN.	USPAT	2003/09/23 17:43
-	2	3,795,047.pn.	USPAT; EPO; JPO; DERWENT	2003/09/23 18:15
-	782345	patternable adhesive	USPAT; EPO; JPO; DERWENT	2003/09/23 18:36
-	2	patternable adj adhesive	USPAT; EPO; JPO; DERWENT	2003/09/23 18:36
-	4	patternable near3 adhesive	USPAT; EPO; JPO; DERWENT	2003/09/24 10:43
-	2	6091194.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 13:47
-	2	6148169.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 15:05
-	2	6288494.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 15:07
-	2	6435928.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 15:08
-	2	6608437.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 15:15
-	2	6608437.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 15:21
-	2	6384592.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 15:26
-	0	6626719.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 15:26
-	0	"METHOD OF MANUFACTURING ELECTRON-EMITTING DEVICE AS WELL AS ELECTRON SOURCE AND IMAGE-FORMING APPARATUS".ti.	USPAT; EPO; JPO; DERWENT	2003/09/24 16:18
-	2	6435928.pn.	USPAT; EPO; JPO; DERWENT	2003/09/24 16:18